

IPW

Attorney Docket : 033082R167

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants : Taaro IKEDA

Serial No. : 10/635,651

Art Unit : 1763

Filed : August 7, 2003

Examiner : Luz L. Alejandro Mulero

For: PLASMA PROCESSING SYSTEM AND PLASMA PROCESSING  
METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the enclosed European Search Report for family member EP application 02711436.2. The enclosed Search Report is dated November 18, 2005. Thus, the following from 1.97(e) is considered applicable for any non-previously made of record reference in this application:

“(1) That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement;”


A copy of each of the non-US references cited in the PTO-1449 form is enclosed.

It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application, and be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

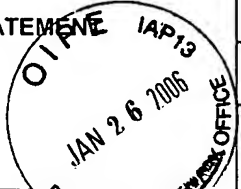
Respectfully submitted,

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January 26, 2006

FORM PTO-1449		ATTY. DOCKET 033082R167	SERIAL NO. 10/635,651
INFORMATION DISCLOSURE STATEMENT 		APPLICANT: Taro Ikeda	
		FILING DATE August 7, 2003	GROUP ART UNIT 1763

### U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	6136139	24 Oct. 2000	Ishii et al.			
	AB	6020686	1 Feb. 2000	Ye et al.			
	AC	6077384	20 June 2000	Collins et al.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

### FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
	AL	0488307A	3 June 1992	EP			YES	NO
	AM	0817237A	7 Jan. 1998	EP				
	AN	WO/01/13403	22 Feb. 2001	WIPO				
	AO							

### OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AP	
	AQ	
	AR	
	AS	
EXAMINER:		DATE CONSIDERED:
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>		